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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hideto Ohnuma et al.                      Art Unit : 2812  
Serial No. : 09/925,512                                      Examiner : Richard A. Booth  
Filed : August 10, 2001                                      Confirmation No.: 4949  
Title : METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT IN REPLY TO ACTION OF MARCH 1, 2004**

Please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 11 of this paper.

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